

Title (en)

METHOD FOR PRODUCING AN OPTOELECTRONIC SEMICONDUCTOR COMPONENT

Title (de)

VERFAHREN ZUR HERSTELLUNG EINES OPTOELEKTRONISCHEN HALBLEITERBAUELEMENTS

Title (fr)

PROCÉDÉ DE FABRICATION D'UN COMPOSANT SEMI-CONDUCTEUR OPTOÉLECTRONIQUE

Publication

**EP 2614538 A1 20130717 (DE)**

Application

**EP 11754342 A 20110829**

Priority

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- EP 2011064836 W 20110829

Abstract (en)

[origin: WO2012031932A1] The invention relates to a method for producing an optoelectronic semiconductor component, wherein electric contacts of the subsequent optoelectronic semiconductor component are prevented from contacting foreign particles of a filler.

IPC 8 full level

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CPC (source: EP KR US)

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Citation (search report)

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